

Application No. 10/564,015
Paper Dated: September 15, 2008
In Reply to USPTO Correspondence of April 25, 2008
Attorney Docket No. 0149-053929

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/564,015 Confirmation No. 4101
Applicants : SHINJI SHIMOSAKI ET AL.
Filed : May 12, 2006
Title : METHOD FOR FORMING METAL OXIDE COATING
FILM AND VAPOR DEPOSITION APPARATUS
Group Art Unit : 1792
Examiner : Francis P. Smith
Customer No. : 28289

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

Sir:

In response to the Office Action dated April 15, 2008, Applicants submit the following remarks. A two-month Petition for Extension of Time, extending the deadline for response to September 15, 2008, along with relevant fee, is also submitted herewith.

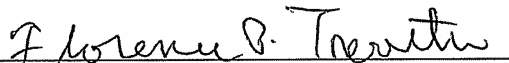
A listing of the Currently Pending Claims begins on page 2 of this paper.

Remarks begin on page 6 of this paper.

I hereby certify that this correspondence is being electronically
submitted to the United States Patent and Trademark Office on
September 15, 2008.

09/15/2008

Date



Signature

Florence P. Trevethan

Typed Name of Person Signing Certificate